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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Akihiko OTOGURO, et al.

Group Art Unit: **1752**

Serial No.: **10/092,310**

Examiner: **WALKE, Amanda C.**

Filed: **March 7, 2002**

P.T.O. Confirmation No.: **8414**

For: **MULTI-LAYERED RESIST STRUCTURE AND MANUFACTURING METHOD
OF SEMICONDUCTOR DEVICE**

Attorney Docket No.: **020201**

Customer No.: **38834**

AMENDMENT UNDER 37 CFR § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 7, 2004

Sir:

In response to the Office Action dated March 9, 2004, please amend the above identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.